Nation of Allowahility	Application No.	Applicant(s)
	10/657,251	NOMURA ET AL.
Notice of Allowability	Examiner	Art Unit
	Alan A. Mathews	2851
The MAILING DATE of this communication appeals all claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85) NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT R of the Office or upon petition by the applicant. See 37 CFR 1.313	(OR REMAINS) CLOSED in this ap) or other appropriate communicatio IGHTS. This application is subject	oplication. If not included n will be mailed in due course. THIS
1. X This communication is responsive to communication filed	<u>3-16-05</u> .	
2. ☑ The allowed claim(s) is/are <u>24-44</u> .		
3. $igotimes$ The drawings filed on <u>06 June 2001</u> are accepted by the E	Examiner.	
 4. Acknowledgment is made of a claim for foreign priority unal	e been received. e been received in Application No. <u>C</u>	·
International Bureau (PCT Rule 17.2(a)).		
* Certified copies not received:		
Applicant has THREE MONTHS FROM THE "MAILING DATE" of this communication to file a reply complying with the requirements noted below. Failure to timely comply will result in ABANDONMENT of this application. THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which give		
6. CORRECTED DRAWINGS (as "replacement sheets") mus	st be submitted.	
(a) ☐ including changes required by the Notice of Draftsperson's Patent Drawing Review (PTO-948) attached		
1) hereto or 2) to Paper No./Mail Date		
(b) including changes required by the attached Examiner' Paper No./Mail Date	's Amendment / Comment or in the	Office action of
Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in t		
7. DEPOSIT OF and/or INFORMATION about the depo attached Examiner's comment regarding REQUIREMENT		
AMach manta)		
Attachment(s) 1. ☐ Notice of References Cited (PTO-892)	5. Notice of Informal I	Patent Application (PTO-152)
2. Notice of Draftperson's Patent Drawing Review (PTO-948)	6. ☐ Interview Summary Paper No./Mail Da	y (PTO-413),
 Information Disclosure Statements (PTO-1449 or PTO/SB/0 Paper No./Mail Date 		
4. Examiner's Comment Regarding Requirement for Deposit		ent of Reasons for Allowance
of Biological Material	9.	Clan a Mathen,
		Alan A. Mathews Primary Examiner

U.S. Patent and Trademark Office PTOL-37 (Rev. 1-04) Application/Control Number: 10/657,251 Page 2

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TERMINAL DISCLAIMER

1. The TERMINAL DISCLAIMER filed March 16, 2005, has been approved and has been entered.

Priority

2. The Examiner has checked the IFW file of the parent application (S.N. 09/923,443) and has found the certified copy of the foreign priority papers, which were filed August 8, 2001.

REASONS FOR ALLOWANCE

3. The following is an examiner's statement of reasons for allowance:

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

The prior art of record does not disclose or suggest at least one diffraction grating pattern being divided into eight regions, each of the regions includes a diffraction grating, and an image of the at least one diffraction grating pattern being projected onto a test substrate Art Unit: 2851

or an image detector by the projection-type exposure apparatus in combination with all the other elements recited in independent claim 24.

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The prior art does not disclose or suggest exposing the image of the at least one diffraction grating pattern and an image of the reference pattern onto the substrate simultaneously, the at least one diffraction grating pattern and the reference pattern comprising a test mark in the evaluation mask; and measuring a relative distance of the image of the at least one diffraction grating pattern formed on the substrate and the image of the reference image formed on the substrate in combination with all the other steps recited in independent claim 35

The prior art does not disclose or suggest exposing the image of the at least one diffraction grating pattern and an image of the reference pattern onto the substrate simultaneously, the at least one diffraction grating pattern and the reference pattern comprising a test mark in the evaluation mask under the condition of $\frac{\lambda}{NA(1-\sigma)} < P < 2 < \frac{\lambda}{NA(1+\sigma)}, \text{ where } \sigma \text{ is a partial coherence of a lighting }$ optical system for lighting the rest mark, P is a period of an image of a first pattern of the test mark, λ is the wavelength of light of the lighting optical system and NA is a numerical aperture of the projection optical system; and measuring the relative distance of the image of the at least one diffraction grating pattern formed on the substrate and the image of the reference image formed on the substrate in combination with all the other elements recited in independent claim 42.

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Alan A. Mathews whose telephone number is (571) 272-2123. The examiner can normally be reached on Monday through Friday from 8:00 AM to 4:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Judy Nguyen can be reached on (571) 272-2258. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Alan A. Mathews Primary Examiner

Celan Walken

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